

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

APPLICANT: Isabelle Chartier et al.  
SERIAL NO.: 10/560,405  
FILING DATE: December 12, 2005 CONFIRMATION NO.: 5533  
TITLE: Method Of Bonding Microstructured Substrates  
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Alexandria, VA 22313-1450

**AMENDMENT AND RESPONSE TO FINAL OFFICE ACTION**

Dear Sir:

This paper is responsive to the Final Office Action mailed April 22, 2008 and is accompanied by a Request for Continued Examination (RCE). Please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of claims, which begins on page 2 of this paper.

**Remarks** begin on page 6 of this paper.